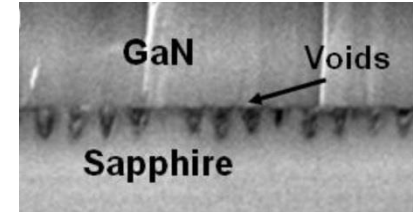
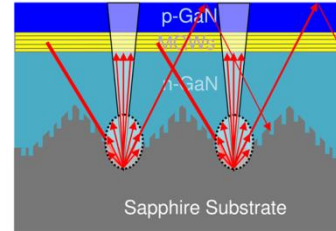
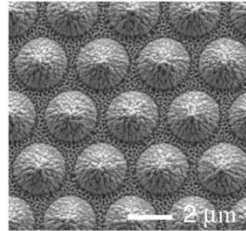


Advanced Thin-film Materials and Devices lab.

✧ Novel patterned substrate for GaN based devices



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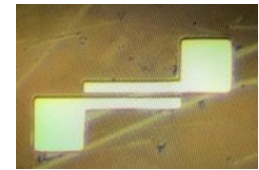
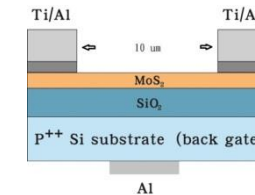
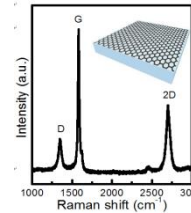
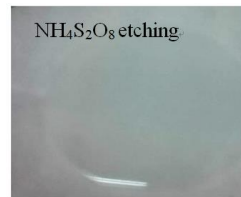
Education:

- Ph.D. Dept. of Electrophysics, National Chiao-Tung University

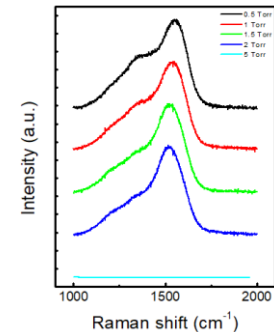
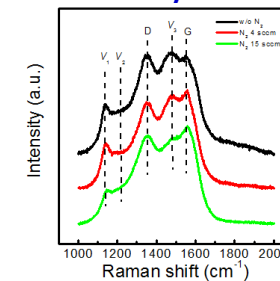
Lectures:

- Engineering Mathematics
- MEMS processes & device applications
- Computer programming & applications
- Industrial Electronics

✧ 2D materials & devices (Graphene & MoS₂)



✧ Carbon related materials (UNCD & DLC)



✧ Semiconductor device characterization

